

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Nobuaki HATORI**

Serial Number: **Not Yet Assigned**

Filed: **August 21, 2003**

For: **METHOD OF MANUFACTURING A SEMICONDUCTOR LASER**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

August 21, 2003

Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and Trademark

Office the references listed on the attached PTO-1449.

A copy of each of the references are enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge

Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (3)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 030941	Serial No. New Application
	Applicant(s): Nobuaki HATORI	
	Filing Date: August 21, 2003	Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____ AE 5-251811	09/28/93	Japan	Yes-Abstract
_____ AF 2001-326421	11/22/01	Japan	Yes-Abstract
_____ AG 9-326506	12/16/97	Japan	Yes-Abstract/Discussed in the specification
_____ AH			
_____ AI			

OTHER DOCUMENTS

_____	AJ	
_____	AK	
Examiner		Date Considered